

**REQUEST  
FOR  
CONTINUED EXAMINATION (RCE)  
TRANSMITTAL**

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,  
provides for continued examination of an utility or  
plant application filed on or after June 8, 1995

Application Number	10/518,013
Confirmation Number	1952
Filing Date	December 14, 2004
First Named Inventor	Yuji EGUCHI
Group Art Unit	1792
Examiner Name	Binh X. Tran
Matter Number	Q85281
Title	OXIDE FILM FORMING METHOD AND OXIDE FILM FORMING APPARATUS

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

**1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114**

- a. ☒ Previously submitted
- i. ☒ Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116  
previously filed on January 22, 2010
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on \_\_\_\_\_
- iii. ☐ Other \_\_\_\_\_
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statements (IDS)
- iv. ☒ Petition for Extension of Time
- v. ☐ Other \_\_\_\_\_

**2. MISCELLANEOUS**

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a  
period of \_\_\_\_\_ months
- b. ☐ Other \_\_\_\_\_

**3. FEES**

The USPTO is directed and authorized to charge the RCE statutory fee of \$810.00 and all required fees, except  
for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said  
Deposit Account.

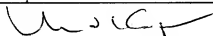
**CORRESPONDENCE ADDRESS**

*Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below:*

WASHINGTON OFFICE  
**23373**  
CUSTOMER NUMBER

**SIGNATURE OF ATTORNEY**

Name Alan J. Kasper Registration No. 25,426

Signature  Date February 23, 2010